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(12) **United States Design Patent**  
**Liu et al.**

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(45) **Date of Patent:** **\*\* Apr. 21, 2020**

(54) **STAND FOR A SURGICAL MICROSCOPE**

- (71) Applicant: **Carl Zeiss Meditec AG**, Jena (DE)
- (72) Inventors: **Jinpeng Liu**, Shanghai (CN); **Xiao Han**, Shanghai (CN); **Sulun Jiang**, Shanghai (CN); **Tao Ma**, Shanghai (CN); **Christian Siegel**, Aalen (DE); **Graham Keevy**, Aalen (DE)
- (73) Assignee: **Carl Zeiss Meditec AG**, Jena (DE)
- (\*\*) Term: **15 Years**
- (21) Appl. No.: **29/659,856**
- (22) Filed: **Aug. 13, 2018**

(30) **Foreign Application Priority Data**

Feb. 13, 2018 (CN) ..... 2018 3 0069661

(51) **LOC (12) Cl.** ..... **16-06**

(52) **U.S. Cl.**  
USPC ..... **D16/131**

(58) **Field of Classification Search**  
USPC ..... D16/130-136; D24/107, 128, 137, 138,  
D24/185, 186, 232, 234  
CPC . G02B 21/004; G02B 21/008; G02B 21/0088  
See application file for complete search history.

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*Primary Examiner* — Holly E Thurman

(74) *Attorney, Agent, or Firm* — Walter Ottesen, P.A.

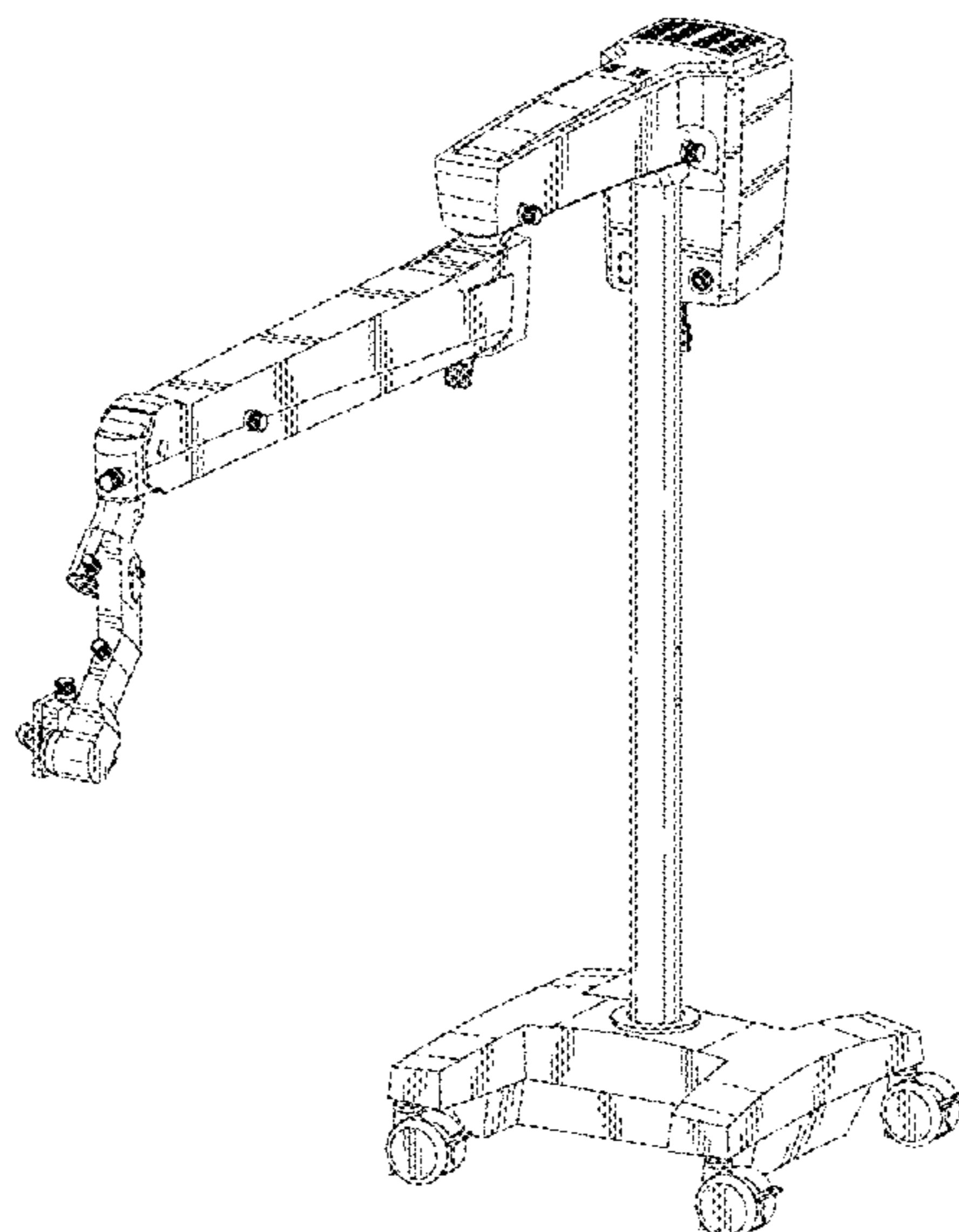
(57) **CLAIM**

The ornamental design for a stand for a surgical microscope, as shown and described.

**DESCRIPTION**

FIG. 1 is a perspective view of the stand for a surgical microscope of our new design;  
 FIG. 2 is a left side elevation view of the stand for a surgical microscope of FIG. 1;  
 FIG. 3 is a right side elevation view of the stand for a surgical microscope of FIG. 1;  
 FIG. 4 is a front elevation view of the stand for a surgical microscope of FIG. 1;  
 FIG. 5 is a rear elevation view of the stand for a surgical microscope of FIG. 1;  
 FIG. 6 is a top plan view of the stand for a surgical microscope of FIG. 1; and,  
 FIG. 7 is a bottom plan view of the stand for a surgical microscope of FIG. 1.  
 The broken lines depict portions of the stand for a surgical microscope that form no part of the claimed design.

**1 Claim, 7 Drawing Sheets**



(56)

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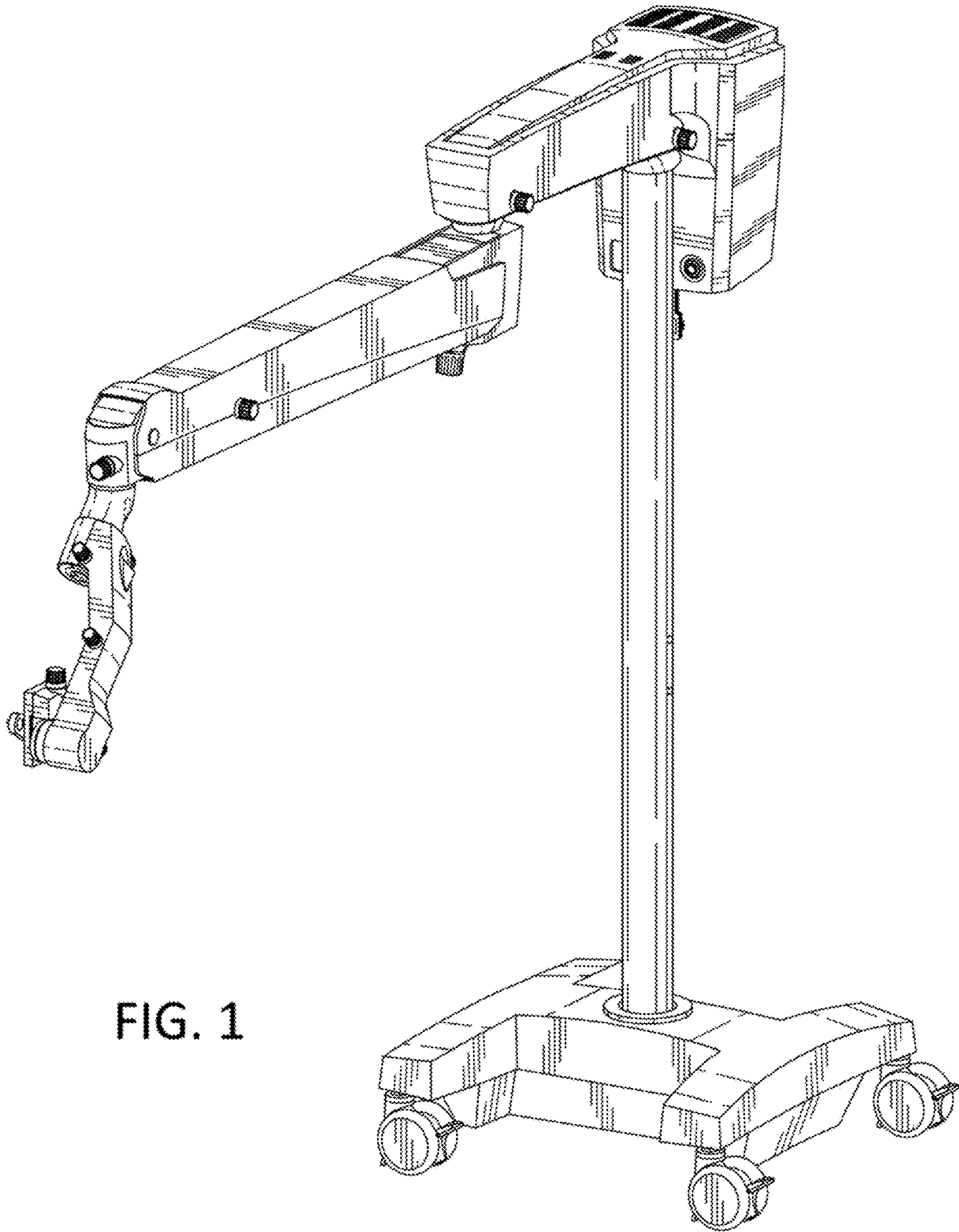


FIG. 1

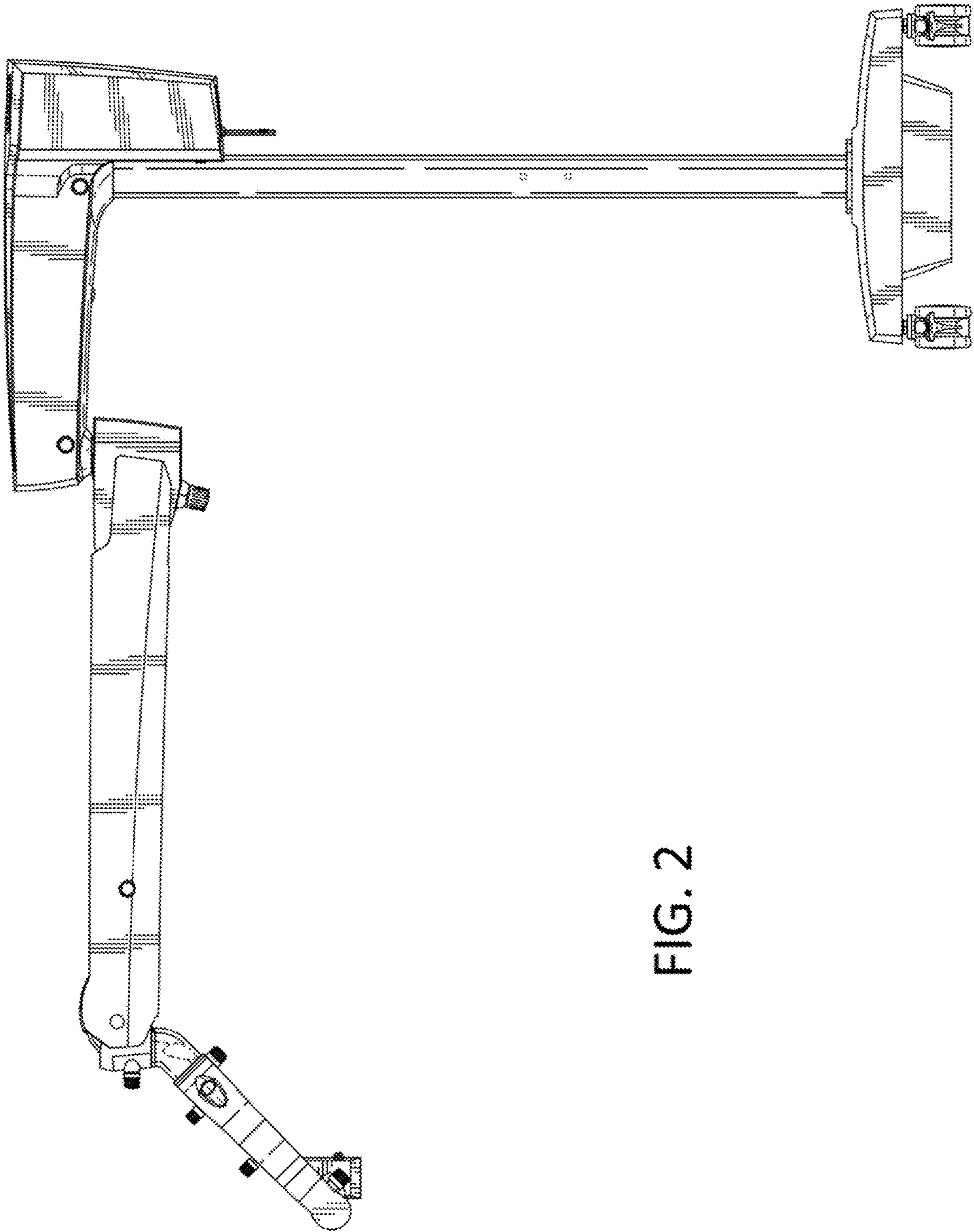


FIG. 2

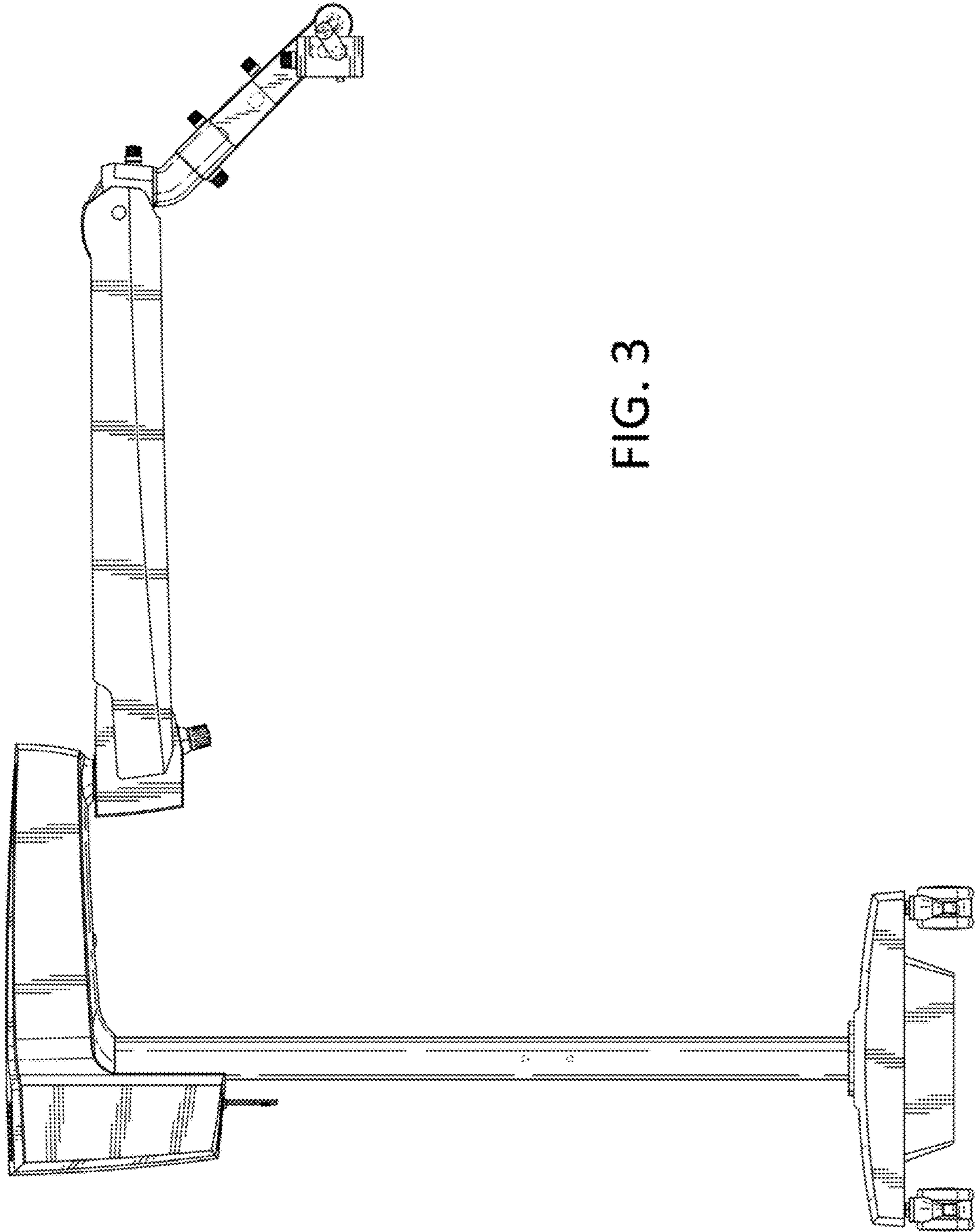


FIG. 3

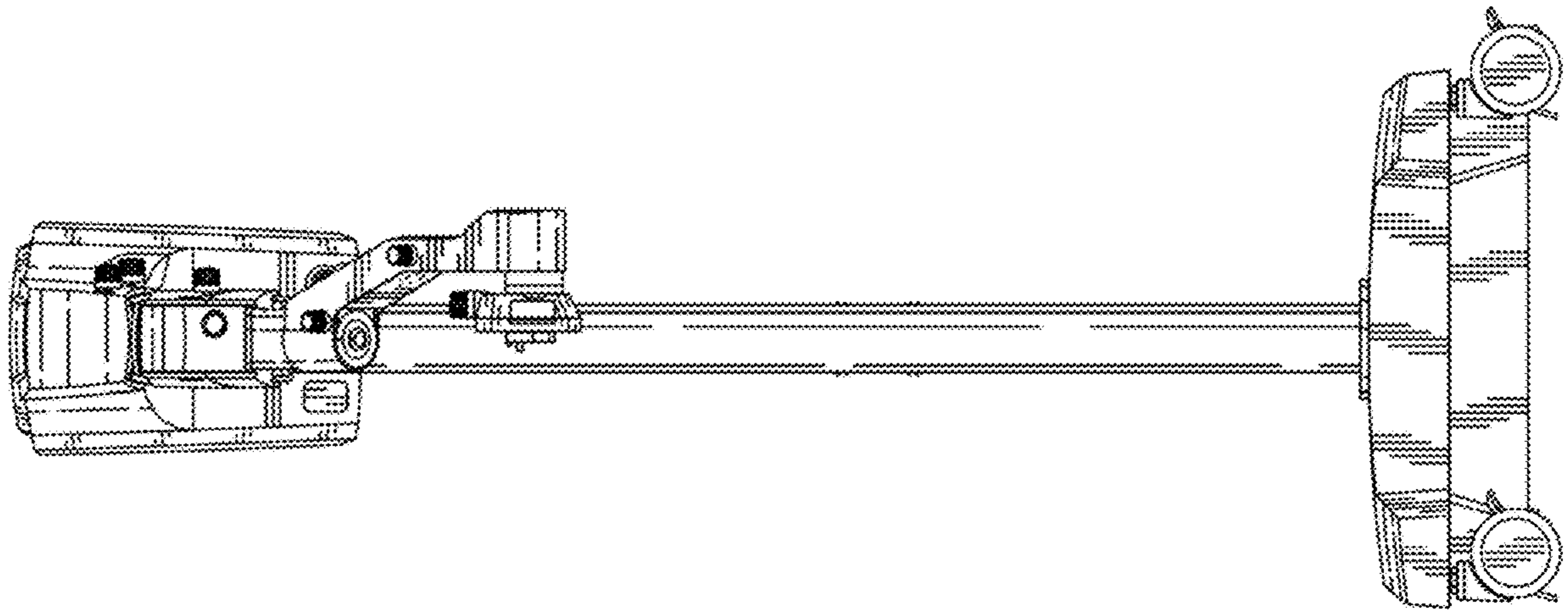


FIG. 4

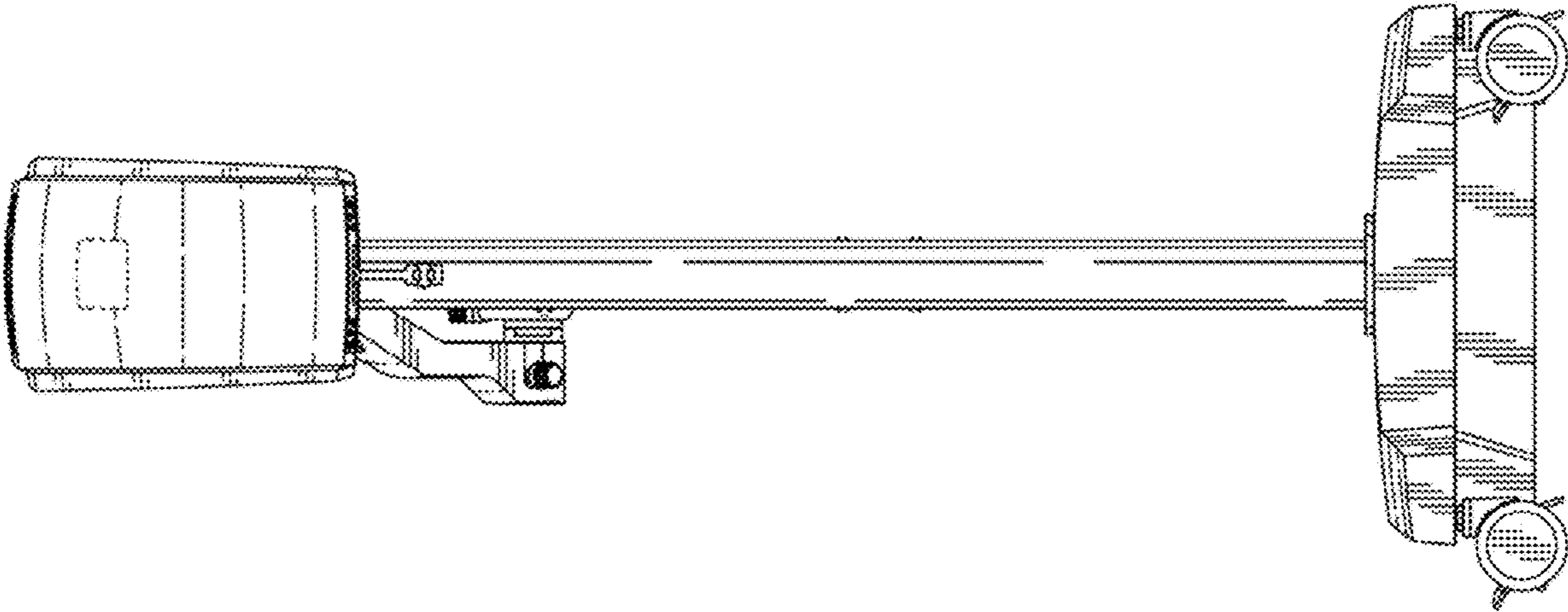


FIG. 5

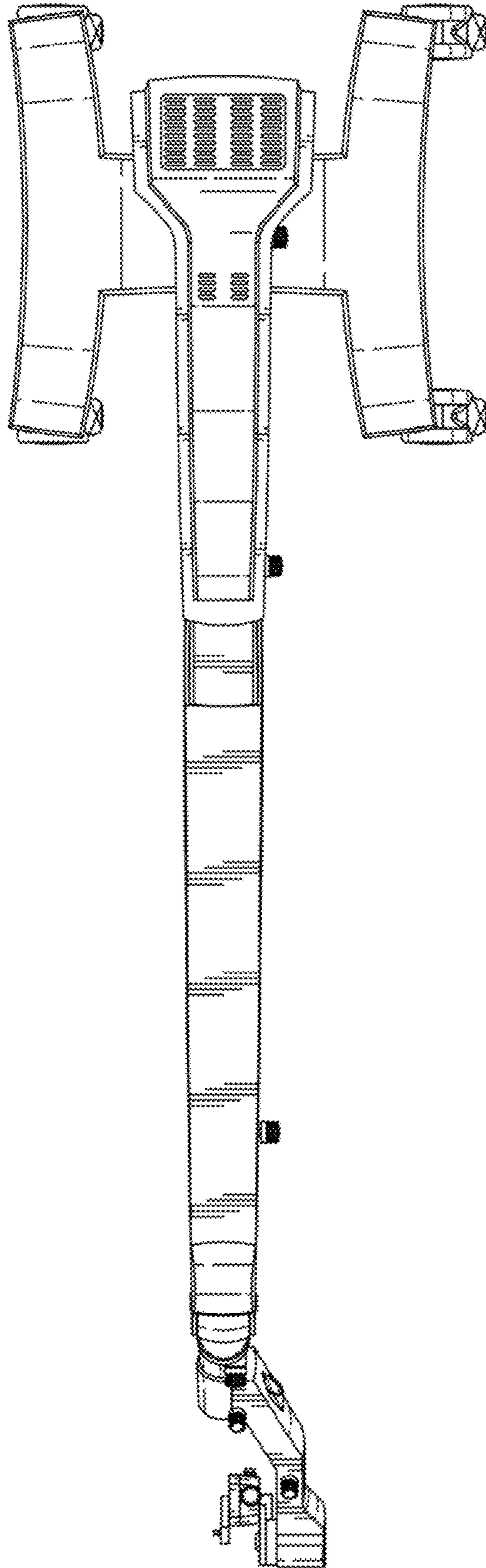


FIG. 6



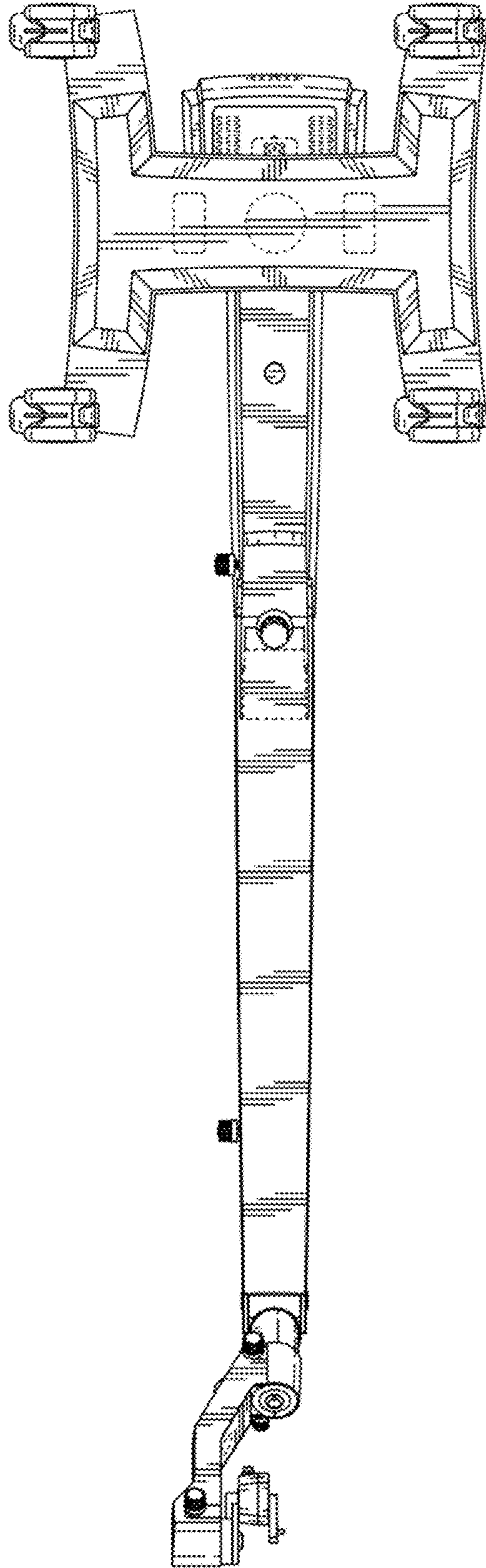


FIG. 7

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : D881,964 S  
APPLICATION NO. : 29/659856  
DATED : April 21, 2020  
INVENTOR(S) : Liu et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Page

On Page 2:

Under (56) Other Publications:

Delete "Aug. 30, 2018" and insert -- Aug. 13, 2018 -- therefor.

Signed and Sealed this  
Fourth Day of August, 2020



Andrei Iancu  
*Director of the United States Patent and Trademark Office*